

PATENT  
Attorney Docket No. 96790P453

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Junko Yotani et al.

Application No.: 10/824,310

Filed: April 13, 2004

For: **METHOD OF MANUFACTURING  
ELECTRON-EMITTING SOURCE**

Examiner: Jie Yang

Art Unit: 1793

Confirmation No.: 5984

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

In response to the Office Action mailed July 9, 2008, in connection with the above referenced patent application, Applicants respectfully request entry of the following amendments and request reconsideration in view of the following remarks.